

APPLICANT'S ART CITATION (Use several sheets if necessary)	Application	OFGS File No. P/2292-52
	Applicant Kyoung-Ri PARK et al	
	Filing Date	Group Art Unit

JC474 USPTO
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U.S. PATENT DOCUMENTS

Examiner Initial	Document Number							Date	Name	Class	Sub-class	Filing Date If Appropriate
	5,	7	9	3,	2	7	6	08/11/98	Tosaka et al	338	22R	

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FOREIGN PATENT DOCUMENTS

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